

Fully depleted monolithic sensors in 110 nm CMOS

Tuesday 26 February 2019 14:20 (20 minutes)

Fully depleted monolithic CMOS sensors allow the prompt collection by drift of large signals. They therefore can offer better signal-to-noise ratio, time resolution and radiation tolerance with respect to conventional solutions. In this presentation, a technology that, thanks to a patterned back-side, allows a full depletion of the substrate in the 100 μm - 400 μm range is presented. The technology is fully compatible with a standard CMOS process. The results obtained on first prototypes fabricated in a 110 nm PDK are presented and near term plans to consolidate the technology platform will be discussed.

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Session Classification: Session 6: CMOS Sensors (1)